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03/09/2006

FACSIMILE TRANSMISSION SHEET

TO: USPTO

(571) 273-8300

FROM: Sandip H. Patel

RE: U.S. Serial No. 10/730,295 (Atty. Docket No. 29936/39864)

PAGES (INCLUDING THIS PAGE): 3

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PATENT

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Applicant:	Kyeong Keun Choi)	I hereby certify that this paper is being
Serial No.:	10/730,295)	facsimile transmitted to the United States
Filed:	December 8, 2003)	Patent and Trademark Office, Fax No.
Title:	METHOD FOR FORMING HIGH RESISTIVE REGION IN SEMICONDUCTOR DEVICE)	(571) 273-8300, on
Group Art Unit:	2813)	March 9, 2006.
Examiner:	David S. Blum)	<i>Sandip Patel</i>
Attorney Docket No.:	29936/39864)	<u>Sandip H. Patel (Reg. No. 43,848)</u> Attorney for Applicant

**PETITION TO WITHDRAW APPLICATION FROM ISSUE
UNDER 37 CFR § 1.313(a) AND (c)(3)**

Mail Stop Express Abandonment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Sir:

The applicant, through the undersigned attorney, hereby petitions to withdraw the above-identified application from issue pursuant to 37 CFR § 1.313(a) and (c)(3). The application was allowed December 23, 2005, and issue and publication fees were mailed February 1, 2006. A notice of express abandonment is submitted herewith.

The \$130.00 fee required under 37 CFR § 1.17(h) may be charged to Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

Sandip Patel
Sandip H. Patel (Reg. No. 43,848)
 Attorneys for Applicant
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 233 South Wacker Drive
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 Telephone: (312) 474-6300

March 9, 2006

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PATENT

**IN THE UNITED STATES PATENT
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Applicant: Kyeong Keun Choi
Serial No.: 10/730,295
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Title: METHOD FOR FORMING
HIGH RESISTIVE REGION
IN SEMICONDUCTOR
DEVICE
Group Art Unit: 2813
Examiner: David S. Blum
Attorney Docket No.: 29936/39864

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(571) 273-8300, on March 9, 2006.


Sandip H. Patel (Reg. No. 43,848)
Attorney for Applicant

~~Sandip H. Patel (Reg. No. 43,848)~~
Attorney for Applicant

Attn: **Attala** (Reg. No. 48,346)
Attorney for Applicant

NOTICE OF EXPRESS ABANDONMENT

**Mail Stop Express Abandonment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450**

Dear Sir:

This paper accompanies a petition under 37 CFR § 1.313(a) and (c)(3) to withdraw the above-identified application from issue.

The applicant, through the undersigned attorney, expressly abandons the above-identified application upon granting the accompanying petition.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP

March 9, 2006

Sandip H. Patel (Reg. No. 43,848)
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Chicago, Illinois 60606-6357
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